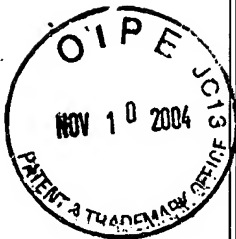


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8836-195 (IB12091-US))

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANTS: Hong-Ki Kim et al. EXAMINER: Chandra P. Chaudhari
SERIAL NO.: 10/629,336 GROUP ART UNIT: 2813
FILED: July 29, 2003
FOR: CAPACITOR FOR A SEMICONDUCTOR DEVICE AND
METHOD OF FABRICATING SAME

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO RESTRICTION REQUIREMENT

Sir:

This paper is submitted in response to the October 7, 2004 Office Action issued by the United States Patent and Trademark Office in connection with the above-identified application. A response to the October 7, 2004 Office Action is due on November 8, 2004. Therefore, this Amendment is being timely filed.

CERTIFICATE OF MAILING 37 C.F.R. § 1.8(a)

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail, postpaid in an envelope, addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on November 8, 2004.

Dated: November 8, 2004


Michael F. Morano